



35.C15513

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OCT 11 2001

PATENT APPLICATION

TC 2800 MAIL ROOM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

SHUJI YAMADA ET AL.

Application No.: 09/847,420

Filed: May 3, 2001

For: ELECTRON SOURCE FORMING  
SUBSTRATE, AND ELECTRON  
SOURCE AND IMAGE  
DISPLAY USING THE SAME

Examiner: Not Yet Assigned

Group Art Unit: 2852

September 6, 2001

Commissioner for Patents  
Washington, D.C. 20231

TECHNOLOGY CENTER 2800

SEP 13 2001

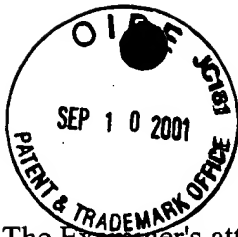
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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. A copy of each listed document is also enclosed.

The concise explanation of relevance for the listed Japanese Patent document may be found in its English-language abstract submitted herewith, in the specification at page 3, where this reference is cited, and in counterpart U.S. Patent 6,208,071, also submitted herewith. The explanation of relevance for the listed Japanese-language article, *Araki*, may be found in the specification at page 2, where this reference is cited.



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The Examiner's attention is also directed to the following U.S. Applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
09/845,286	05/01/01	2879
09/846,364	05/02/01	1753

A copy of each cited Application, as originally filed, is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

*R. P. Diana*  
Attorney for Applicants

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